

COMBINED DECLARATION, POWER OF ATTORNEY AND PETITION

I, the inventor,

Name: Peter CHOI
Residence: ORSAY - FRANCE
Post Office Address: 33, rue de la Corniche
91400 ORSAY - FRANCE
Citizenship: French

declare that I have reviewed and understand the contents of the attached specification and claims and I verily believe that I am the original, first and sole inventor or discoverer of the invention or discovery in

PLASMA SOURCE OF DIRECTED BEAMS AND APPLICATION THEREOF TO MICROLITHOGRAPHY

described and claimed in the attached specification; that this application in part discloses and claims subject matter disclosed in my earlier filed pending application(s) of which I hereby claim the benefit under 35 U.S.C., Section 119 (a)-(d), _____, filed _____; that as to the subject matter of this application which is common to any said earlier application(s), I do not know and do not believe that the same was ever known or used in the United States before my invention or discovery thereof; that to the best of my knowledge and belief the invention of said common subject matter has not been in public use or on sale in the United States more than one year prior to the earliest of said application(s) or patented or described in any printed publication in any country before my invention thereof or more than one year prior to the earliest of said application(s), or patented or made the subject of an inventor's certificate in any foreign country prior to the date of the earliest of said application(s) on an application filed by myself or my legal representatives or assigns more than twelve months prior to the earliest of said application(s) in this country; and that no application for patent or inventor's certificate on the invention or discovery of said common subject matter has been filed by me or my legal representatives or assigns in any country foreign to the United States, except as follows:

Country	Serial No.	Filing Date
FRANCE	031 2202	October 17, 2003

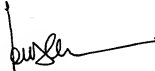
that as to the subject matter of this application which is not common to said earlier application(s), I do not know and do not believe that the same was ever known or used in the United States before my invention or discovery thereof; that to the best of my knowledge and belief the invention thereof has not been in public use or on sale in the United States more than one year prior to this application or patented or described in any printed publication in

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DECLARATION

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

20 APRIL, 2006
Date


Peter CHOI

ASSIGNMENT

WHEREAS, the following inventor

Name: Peter CHOI
Residence: ORSAY - FRANCE
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91400 ORSAY - FRANCE
Citizenship: French

hereinafter referred to as ASSIGNOR, have invented certain new and useful improvements in an invention entitled:

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which is described and claimed in an application for Letters Patent of the United States executed by ASSIGNOR on even date herewith, and naming as sole inventor _____; said improvements as described and claimed in said application for Letters Patent of the United States, being hereinafter referred to as said "Invention"; and

WHEREAS, EPPRA,
a Corporation duly organized and existing under and by virtue of
the laws of the Country of FRANCE and having its principal office
and place of business at 16, avenue du Québec

Parc d'Affaires Silic de Villebon Courtaboeuf
91140 VILLEBON SUR YVETTE - FRANCE

hereinafter referred to as ASSIGNEE, is desirous of acquiring ASSIGNOR'S entire rights, title and interest in and to said Invention, and in, to and under Letters Patent therefor in the United States;

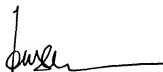
NOW THEREFORE BE IT KNOWN THAT, for and in consideration of good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, ASSIGNOR has sold, assigned, transferred and set over and by these presents do hereby sell, assign, transfer and set over to and unto ASSIGNEE, its successors and assigns ASSIGNOR'S entire rights, title and interest in and to said Invention, and in, to and under the above-identified application and all other applications for Letters Patent of the United States, and in, to and under all divisions, reissues, continuations, extensions and reexaminations thereof, and covenant that ASSIGNOR has the full right so to do; and the Commissioner of Patents is hereby authorized and requested to issue all United States Letters Patent on said Invention included herein to ASSIGNEE, as assignee of ASSIGNOR'S entire interest.

ASSIGNMENT

ASSIGNOR further agrees to communicate to ASSIGNEE or its representatives or agents all facts and information known or available to ASSIGNOR regarding said Invention including evidence for interference purposes or for other legal proceedings, whenever requested; to testify in any interference or other proceedings; to execute and deliver, on request, all lawful papers including original, divisional, continuing and reissue applications, renewals, assignments, powers of attorney, declarations, oaths, affidavits, depositions, etc.; and to generally do everything possible to aid ASSIGNEE, its successors and assigns, but at the expense of ASSIGNEE, in obtaining and enforcing proper protection for said Invention in the United States.

20 April 2006

Date

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Peter CHOI